

Notice of References Cited	Application/Control No. 10/633,580		Applicant(s)/Patent Under Reexamination TANISHIMA ET AL.	
	Examiner Ly D. Pham		Art Unit 2827	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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